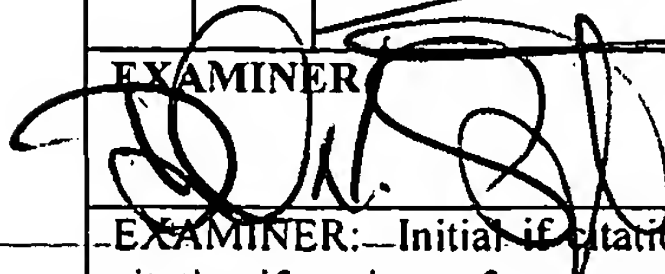


(PART OF #1A/IDS)

PTO-1449		Application No. 10644721		Applicant(s) Mohammed N. Islam et al.			
Information Disclosure Citation in an Application		Docket Number 074036.0124		Group Art Unit 2873		Filing Date August 20, 2003	
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DIS	A	2002/0035193 A1	02/20/2003	Islam et al.	359	290	08/22/2002
DIS	B	6,407,851 B1	06/18/2002	Islam et al.	359	291	08/01/2000
DIS	C	2003/0081878 A1	05/01/2003	Joyner et al.	385	14	10/08/2002
DIS	D	2003/0086465 A1	05/08/2003	Peters et.al.	372	50	10/30/2002
DIS	E	2003/0095736 A1	05/22/2003	Kish, JR. et al.	385	14	10/08/2002
DIS	F	2003/0095737 A1	05/22/2003	Welch et al.	385	14	10/08/2002
DIS	G	6,611,366 B1	08/26/2003	Islam et al.	359	291	04/22/2002
	H						
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		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
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NON-PATENT DOCUMENTS							
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(PART of # 1B/IDS)

PTO-1449		Application No. 10/644721		Applicant(s) Mohammed N. Islam et al.				
Information Disclosure Citation in an Application		Docket Number 074036.0124		Group Art Unit 2873	Filing Date August 20, 2003			
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		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
DIS	A	4,011,009	03/08/77	Lama, et al.	359-350	27-462-R	05/27/75	
	B	4,900,119	02/13/90	Hill, et al.	359-350	571-96-45	04/01/88	
	C	5,103,340	04/07/1992	Dono et al.	385	46	08/07/1991	
	D	5,212,743	05/18/93	Heismann	385	11	02/12/92	
	E	5,291,502	03/01/1994	Pezeshki et al.	372	20	09/04/1992	
	F	5,311,360	05/10/94	Bloom, et al.	359	572	04/28/92	
	G	5,343,542	08/30/1994	Kash et al.	385	31	04/22/1993	
	H	5,459,610	10/17/95	Bloom, et al.	359	572	05/20/93	
	I	5,500,761	03/19/96	Goossen, et al.	359	290	01/27/94	
	J	5,654,819	08/05/97	Goossen, et al.	359	291	01/07/95	
	K	5,659,418	08/19/97	Yurke	359	290	02/05/96	
	L	5,661,592	08/26/97	Bornstein, et al.	359	291	01/07/95	
	M	5,701,193	12/23/97	Vogel, et al.	359	290	02/21/96	
	N	5,745,271	04/28/98	Ford, et al.	359	130	07/31/96	
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	P	0 689 078 A1	27.12.1995	EP	G02B	26/08	X	
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	S	C. M. Ragdale, et al., "Integrated Three Channel Laser and Optical Multiplexer for Narrowband Wavelength Division Multiplexing," Electronics Letters, Vol. 30, No. 11, pp. 897-898						05/26/94
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PTO-1449 Information Disclosure Citation in an Application	Application No. 10/644721	Applicant(s) Mohammed N. Islam et al.	
	Docket Number 074036.0124	Group Art Unit 2873	Filing Date August 20, 2003

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	B	5,774,252	06/30/1998	Lin et al.	359	224	04/19/1996
	C	5,825,528	10/20/98	Goossen	359	291	12/26/95
	D	5,835,255	11/10/98	Miles	359	291	05/05/94
	E	5,841,579	11/24/98	Bloom, et al.	359	572	06/07/95
	F	5,850,492	12/15/98	Morasca, et al.	385	11	11/06/96
	G	5,870,221	02/09/99	Goossen	359	290	07/25/97
	H	5,909,303	06/01/1999	Trezza et al.	359	248	01/03/1997
	I	5,914,804	06/22/99	Goossen	359	291	01/28/98
	J	5,920,391	07/06/1999	Grasdepot et al.	356	352	04/22/1998
	K	5,943,155	08/24/99	Goossen	359	247	08/12/98
	L	5,943,158	08/24/99	Ford, et al.	359	295	05/05/98
	M	5,943,454	08/24/99	Aksyuk, et al.	385	22	08/15/97
	N	5,949,571	09/07/99	Goossen, et al.	359	291	07/30/98

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(PART of #186DS)

PTO-1449 Information Disclosure Citation in an Application	Application No. 10/644 721 Docket Number 074036.0124	Applicant(s) Mohammed N. Islam et al. Group Art Unit 2873 Filing Date August 20, 2003
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↓	B	5,960,133	09/28/99	Tomlinson	385	18	01/27/98
↓	C	5,974,207	10/26/99	Aksyuk, et al.	385	24	12/23/97
↓	D	5,986,796	11/16/99	Miles	359	260	11/05/96
↓	E	5,999,319	12/07/1999	Castracane	359	573	04/29/1998
↓	F	6,002,513	12/14/99	Goossen, et al.	359	291	06/22/98
↓	G	6,025,950	02/15/2000	Tayebati et al.	359	244	07/27/1998
↓	H	6,041,071	03/21/2000	Tayebati	372	64	09/27/1996
↓	I	6,123,985	09/26/2000	Robinson et al.	427	162	10/28/1998
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↓	M	6,301,274 B1	10/09/2001	Tayebati et al.	372	20	03/30/1999

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D/S	N	01/67156 A2	13.09.2001	WO	G02B	26/00	X	
↓	O	01/67157 A2	13.09.2001	WO	G02B	26/00	X	
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↓	Q	01/67171 A2	13.09.2001	WO	G02F	1/21	X	
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D/S	S	D.M. Burns, et al., "Micro-Electro-Mechanical Variable Blaze Gratings," IEEE 10th Annual International Workshop on Micro Mechanical Systems, pp. 385-391	1997
↓	T	L.Y. Lin, et al., "Micromachined polarization-state controller and its application to polarization-mode dispersion compensation," OFC 2000, Baltimore, MD, pp. ThQ3-1, 244-246	2000
↓	U	J.W. Bayless, et al., "High Density Digital Data Transmission," National Telecommunications Conference, Dallas, TX, pp. 1-6	1976
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(PART OF #18/IDS)

PTO-1449	Application No. 10/644721	Applicant(s) Mohammed N. Islam et al.	
Information Disclosure Citation in an Application	Docket Number 074036.0124	Group Art Unit 2873	Filing Date August 20, 2003

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	B	6,373,632 B1	04/16/2002	Flanders	359	578	08/25/2000
	C	6,381,387 B1	04/30/2002	Wendland, Jr.	385	37	08/02/00
	D	2002/0105697 A1	08/08/2002	Fabiny	359	128	02/12/02
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DAS ↓ ↓ ↓ ↓ ↓	F	WO 01/37021 A1	14.11.2000	PCT	G02B	6/42	X	
	G	WO 01/79795 A1	22.03.2001	PCT	G01J	3/28	X	
	H	WO 02/056521 A1	02.11.2001	PCT	H04J	14/00	X	
	I	WO 02/059655 A2	20.12.2001	PCT	G02B		X	
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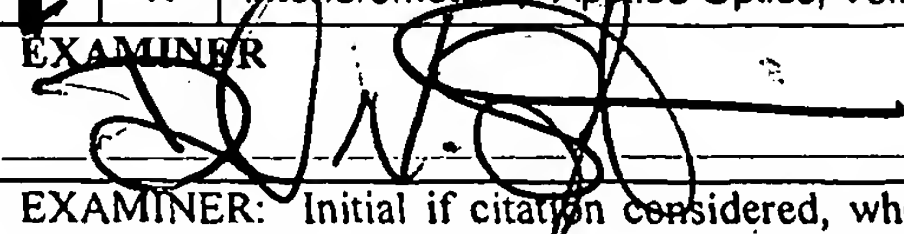
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DAS ↓	L	SLM "GLV Technology," www.siliconlight.com	1999
	M	R.W. Corrigan, et al., "Grating Light Valve Technology for Projection Displays," Presented at the International Display Workshop, Kobe, Japan	1998
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(PART OF #18 LIDS)

PTO-1449		Application No. 10/644721		Applicant(s) Mohammed N. Islam et al.				
Information Disclosure Citation in an Application		Docket Number 074036.0124		Group Art Unit 2873	Filing Date August 20, 2003			
U.S. PATENT DOCUMENTS								
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DIS	B	WO 01/37021 A1	14.11.2000	PCT	G02B	6/42	X	
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	D	WO 02/056521 A1	02.11.2001	PCT	H04J	14/00	X	
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	G	C.K. Madsen, et al., "A Tunable Dispersion Compensating MEMS All-Pass Filter," IEEE Photonics Technology Letters, Vol. 12 (6), pp. 651-653					2000	
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	N	E.P. Furlani, et al., "Analysis of grating light valves with partial surface electrodes," American Institute of Physics, Vol. 83 (2), pp. 629-634					1998	
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(PART of #1B/IDS)

PTO-1449 Information Disclosure Citation in an Application	Application No.	Applicant(s)	
	10/644 721	Mohammed N. Islam et al.	
	Docket Number	Group Art Unit	Filing Date
	074036.0124	2873	August 20, 2003

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	C	WO 02/10822 A1	31.07.2001	PCT	G02B	6/34	X	
	D	WO 02/21191 A1	07.09.2001	PCT	G02B	27/10	X	
DIS	E	WO 02/50588 A1	20.12.2001	PCT	G02B	6/26	X	
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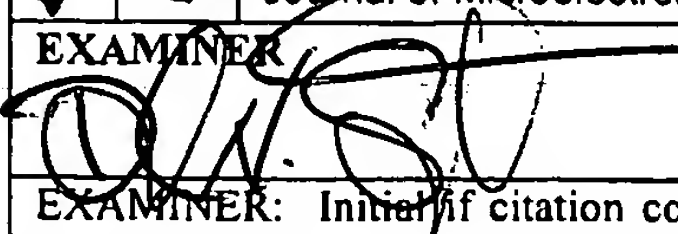
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PTO-1449		Application No. 10/644 721		Applicant(s) Mohammed N. Islam et al.				
Information Disclosure Citation in an Application		Docket Number 074036.0124		Group Art Unit 2873	Filing Date August 20, 2003			
U.S. PATENT DOCUMENTS								
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
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	E	Tayebati et al., "Microelectromechanical tunable filter with stable half symmetric cavity," Electronics Letters, Vol. 34, No. 20, pp. 1967-1968						10/01/1998
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PTO-1449

Information Disclosure Citation
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Application No.
10/644721

Docket Number
074036.0124

Applicant(s)
Mohammed N. Islam et al.

Group Art Unit
2873

Filing Date
August 20, 2003

U.S. PATENT DOCUMENTS

		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	A						
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FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	M							

NON-PATENT DOCUMENTS

		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
DIS	N	Goossen et al., "Micromechanical Gain Slope Compensator for Spectrally linear Optical Power Equalization," IEEE Photonics Technology Letters, Vol. 12, No. 7, pp. 831-833	07/2000
DIS	O	Goossen et al., "Integrated mechanical anti-reflection switch (MARS) device for fiber-to-the-home applications," http://mirlynweb.lib.umich.edu/WebZ/FETCH?sessionid=01-35557-462149016&recno=13&re	05/08/2002
DIS	P	"ELASTIC-45 tunable interferometer component," Solus, Preliminary Datasheet and applications	Undated
	Q		
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EXAMINER

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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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